

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/829,392	WAGNER ET AL.	
	Examiner	Art Unit	Page 1 of 4
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	W	Scott; Overview of Spin Coating; 12/01/2000; www.polymerprocessing.com□□
	X	Knowles et al.; Micromachining of Metals, Ceramics, Silicon and Polymers using Nanosecond Lasers

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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